		0 1 7 7	DB	Time stamp
L Number	Hits	Search Text	DB USPAT;	2003/04/28 06:11
-	750	imag\$3 and semiconduct\$3 and pixel and electronic and silicon and (detector or	US-PGPUB	2003/04/20 00.11
		electronic and sillcon and (detector of	US-FGFUB	
	222004	sensor) and read and layer and deposit\$3 (imag\$3 and semiconduct\$3 and pixel and	USPAT;	2003/04/23 09:54
-	333894	electronic and silicon and (detector or	US-PGPUB	2003/04/23 07.34
		sensor) and read and layer and deposit\$3)	35 7 61 015	
		and matrix or array		
	729	(imag\$3 and semiconduct\$3 and pixel and	USPAT;	2003/04/23 10:21
[-	129	electronic and silicon and (detector or	US-PGPUB	
		sensor) and read and layer and deposit\$3)	55 15105	
1		and (matrix or array)		
1_	7	((imag\$3 and semiconduct\$3 and pixel and	USPAT;	2003/04/23 10:22
1	1	electronic and silicon and (detector or	US-PGPUB	
İ		sensor) and read and layer and deposit\$3)		
		and (matrix or array)) and vaporization		
1_	308	((imag\$3 and semiconduct\$3 and pixel and	USPAT;	2003/04/23 10:22
-	308	electronic and silicon and (detector or	US-PGPUB	
	1	sensor) and read and layer and deposit\$3)	35 13105	
1		and (matrix or array)) and vapor\$		
_	308	((imag\$3 and semiconduct\$3 and pixel and	USPAT;	2003/04/23 16:54
=		electronic and silicon and (detector or	US-PGPUB	
	1	sensor) and read and layer and deposit\$3)		
		and (matrix or array)) and vapor\$7		
_	6	close adj space adj vapor adj transport	USPAT;	2003/04/23 17:37
		and after any taken any enterior	US-PGPUB	
-	0	(close adj space adj vapor adj transport)	USPAT;	2003/04/23 17:38
		and imag\$3	US-PGPUB	
_	77	250/370.12.ccls.	USPAT;	2003/04/23 17:39
			US-PGPUB	
_	378	250/338.4.ccls.	USPAT;	2003/04/23 17:39
			US-PGPUB	
-	1172	250/338.1.ccls.	USPAT;	2003/04/23 17:40
			US-PGPUB	•
-	515	250/336.1.ccls.	USPAT;	2003/04/23 17:40
•			US-PGPUB	
-	483	250/370.01.ccls.	USPAT;	200 /04/23 17:41
			US-PGPUB	0000/04/05 55 55
-	135	250/370.13.ccls.	USPAT;	2003/04/23 17:41
		0-0/000 /	US-PGPUB	2002/04/02 17:40
-	2415	250/370.12.ccls. or 250/338.4.ccls. or	USPAT;	2003/04/23 17:42
		250/338.1.ccls. or 250/336.1.ccls. or	US-PGPUB	
		250/370.01.ccls. or 250/370.13.ccls.	IICDAE -	2003/04/23 17:42
-	842	(250/370.12.ccls. or 250/338.4.ccls. or	USPAT; US-PGPUB	2003/04/23 17:42
		250/338.1.ccls. or 250/336.1.ccls. or	US-PGPUB	
		250/370.01.ccls. or 250/370.13.ccls.) and		
	227	imag\$3 ((250/370.12.ccls. or 250/338.4.ccls. or	USPAT;	2003/04/23 17:44
-	337	250/338.1.ccls. or 250/336.1.ccls. or	US-PGPUB	2003/04/23 17.44
		250/338.1.ccis. or 250/336.1.ccis. of 250/370.13.ccis.) and	OD EGEOD	
		imag\$3) and pixel		,
_	236	1	USPAT;	2003/04/24 11:42
-	230	250/338.1.ccls. or 250/336.1.ccls. or	US-PGPUB	
		250/330.1.ccls. of 250/330.1.ccls.) and		
		imag\$3) and pixel) and semiconduct\$3		
_	1	l . T	USPAT;	2003/04/23 17:45
		semiconduct\$3 and pixel and electronic and	US-PGPUB	
		silicon and (detector or sensor) and read		
		and layer and deposit\$3) and (matrix or		
		array)) and vapor\$7)) and (array or		
		matrix)		
	. 0	(matrix or array) and semiconduct\$3 and	USPAT;	2003/04/24 11:44
		pixel and silicon and (reading adj panel)	US-PGPUB	
		and electronic and (vapor adj deposition)		<u> </u>
-	3029	(matrix or array) and semiconduct\$3 and	USPAT;	2003/04/24 11:45
		pixel and (vapor adj deposition)	US-PGPUB	
-	0	(matrix or array) and semiconduct\$3 and	USPAT;	2003/04/24 11:45
		pixel and (reading adj panel) and	US-PGPUB	
1		electronic and (vapor adj deposition)		

				2003/04/24 11:45
-	0	(matrix or array) and semiconduct\$3 and	USPAT;	2003/04/24 11:45
		pixel and (reading adj panel) and (vapor	US-PGPUB	
		adj deposition)		
-	2875	((matrix or array) and semiconduct\$3 and	USPAT;	2003/04/24 11:46
		pixel and (vapor adj deposition)) and	US-PGPUB	
		(silicon or SI)		
- 1	2225	(((matrix or array) and semiconduct\$3 and	USPAT;	2003/04/24 11:46
		pixel and (vapor adj deposition)) and	US-PGPUB	
		(silicon or SI)) and imag\$3		
-	848		USPAT;	2003/04/24 11:47
		pixel and (vapor adj deposition)) and	US-PGPUB	
		(silicon or SI)) and imag\$3) and (detector		
		or sensor)		
-	575		USPAT;	2003/04/24 11:54
		and pixel and (vapor adj deposition)) and	US-PGPUB	
		(silicon or SI)) and imag\$3) and (detector		
		or sensor)) and integrated		
-	81979	(vapor adj deposition)	USPAT;	2003/04/24 11:54
			US-PGPUB	
-	9324	(vapor adj deposition) with semiconductor	USPAT;	2003/04/24 11:55
			US-PGPUB	0000/04/04 11 55
-	187	(vapor adj deposition) near semiconductor	USPAT;	2003/04/24 11:55
			US-PGPUB	
-	10		USPAT;	2003/04/24 12:01
		semiconductor) and imag\$3	US-PGPUB	
-	1400	` ` -	USPAT;	2003/04/24 12:03
	İ	semiconductor) and imag\$3	US-PGPUB	0000/04/04 10 00
-	335		USPAT;	2003/04/24 12:03
		semiconductor) and imaging	US-PGPUB	0000/04/00 06 10
-	9825	(vapor adj deposition) with semiconduct\$3	USPAT;	2003/04/28 06:12
			US-PGPUB	0003/04/00 06 10
-	476	' '	USPAT;	2003/04/28 06:12
) and pixel	US-PGPUB	2002/04/20 06:12
-	4		USPAT;	20.03/04/28 06:12
		semiconduct\$3) and pixel) and	US-PGPUB	
		scintillat\$3		L